

FACSIMILE TRANSMITTAL FORM	Application Number	10/734684
	Filing Date	December 12, 2003
	First Named Inventor	Theiss, Steven D
	Art Unit	1765
	Examiner Name	DEO, Duy Vu Nguyen
Fax: 571-273-8300	Attorney Docket Number	58355US002
Total Number of Pages in This Submission: 13		RECEIVED CENTRAL FAX CENTER
Date: JULY 18, 2005	Attorney for Applicant: Lisa P. Fulton JUL 18 2005	

ENCLOSURES (check all that apply)		
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<input type="checkbox"/> Amendment/Reply <input type="checkbox"/> After Final <input type="checkbox"/> Affidavits/Declaration(s)	<input type="checkbox"/> Petition to Convert a Provisional Application	<input type="checkbox"/> Appeal Communication to Technology Center (Appeal Notice, Brief, Reply Brief)
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Patent
Case No.: 58355US002

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

First Named Inventor: THEISS, STEVEN D
Application No.: 10/734684 Group Art Unit: 1765
Filed: December 12, 2003 Examiner: DEO, Duy Vu Nguyen
Title: METHOD FOR PATTERNING FILMS

INFORMATION DISCLOSURE STATEMENT

Mail Stop: Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

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Dear Sir:

Pursuant to 37 CFR §§ 1.56, 1.97, and 1.98, enclosed is a completed Form PTO-1449, citing references submitted for consideration by the Examiner. It is respectfully requested that the Examiner initial and return the enclosed Form PTO-1449 to indicate that each reference has been considered.

Copies of any cited foreign patents, foreign publications, non-patent literature documents, and any pending U.S. applications filed before June 30, 2003, are enclosed. Copies of any pending U.S. applications filed after June 30, 2003 that can be accessed on the USPTO's IFW system are not enclosed as per USPTO Waiver dated September 21, 2004. Copies of any U.S. patents and published U.S. patent applications are not enclosed. Under 37 CFR § 1.97(e)(1), I hereby certify that each item of information contained in this Information Disclosure Statement was first cited in any communication from a foreign patent office in a counterpart foreign application not more than three (3) months prior to the filing of this Information Disclosure Statement.

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designated in 37 CFR § 1.56(c) more than thirty (30) days prior to the filing of this Information Disclosure Statement.

A copy of the Search Report from a foreign counterpart application is enclosed.

It is believed that no fee is due; however, in the event a fee is required, please charge the fee to Deposit Account No. 13-3723.

Respectfully submitted,

July 15, 2005
Date

By: Lisa P. Fulton
Lisa P. Fulton, Reg. No.: 55,195
Telephone No.: (651) 733-1260

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Substitute for form 1449A/PTO (modified) INFORMATION DISCLOSURE STATEMENT BY APPLICANT (Use as many sheets as necessary) Page 1 of 1	Application Number	10/734684
	Filing Date	December 12, 2003
	First Named Inventor	Thelss, Steven D
	Art Unit	1765
	Examiner Name	DEO, Duy Vu Nguyen
	Attorney Case Number	58355US002

U.S. Patent Documents					
Exam. Init.*	Cite No.	Document Number	Publication Date or Issue Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
		Doc. Number-(Kind Code (if known))			
	A1	US-			
	A2	US-			
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	A4	US-			
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		Ctry. Code	Number-KindCode (if known)				
	B1						
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OTHER DOCUMENTS			
Exam. Init.*	Cite No.	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published	Translation (Check if yes)
	C1	KIM et al., "Fabrication and Application of a Full Wafer Size Micro/Nanostencil for Multiple Length-Scale Patterning", Microelectronic Engineering, (2003), pp. 609-614, Vol. 67-68	
	C2		
	C3		

*Examiner:	Date Considered:
EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.	